



45681

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
Michael K. DENK et al.	:	Art Unit: 1762
Serial No.: 10/643,090	:	Examiner: K. Stouffer
Filed: August 19, 2003	:	
For: A NEW CLASS OF VOLATILE	:	
COMPOUNDS FOR THE DEPOSITION	:	
OF THIN FILMS OF METALS AND	:	
METAL COMPOUNDS	:	

**AMENDMENT AND
RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the September 20, 2006 Office Action, please amend the above-identified application as follows.

11/21/2006 SZEWDIE1 00000138 10643090

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